

501.41175X00/340101349US1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki NAKANO *et al.*  
Serial No.: 10/075,244  
Filed: 15 February 2002  
For: METHOD AND APPARATUS FOR PLASMA PROCESSING  
Group: 1762  
Examiner: M. Padgett  
Conf. No.: 7857

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NOTICE OF APPEAL

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EXPEDITED PROCESSING REQUESTED UNDER 37 CFR §1.116

Commissioner for Patents

P.O. Box 1450

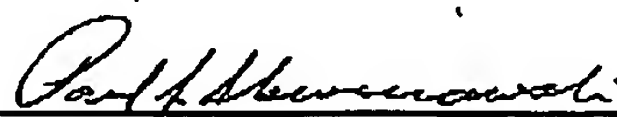
Alexandria, Virginia 22313-1450

18 April 2005

Sir:

Applicant respectfully appeals the decision of the Examiner in finally rejecting Claims 1-18 (Claims 19-35 are pending but withdrawn from consideration) in the Office Action mailed 18 November 2004 in connection with the above-identified application. A PTO-2038 authorizing payment of all fees required for entry of this paper is being filed concurrently herewith. Please charge any actual fee deficiency to ATS&K Deposit Account No. 01-2135 (as Case No. 501.41175X00).

Respectfully submitted,



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